

FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. 134446		SERIAL NO.	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <u>LIST OF ITEMS</u>				Applicant Chayan Mitra, et al			
				Filing Date		Group	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	Filing Date If Appropriate	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>DAW</i>	C1	Y. Uesugi, et al, "Generation of high heat flux plasmas by high power rf heating in the divertor plasma simulator NAGDIS-II", Vacuum 59 (2000) pp: 24 -34					
<i>{</i>	C2	Y.M. Sung et al, "A review of SiC Static induction transistor development for high frequency power amplifiers", Solid-State Electronics 46 (2002) pp: 605-613					
<i>{</i>	C3	S. Ortolland et al, "Optimisation of a power 4H-SiC SIT device for RF heating applications", Materials Science and Engineering B 61-62 (1999) pp: 411-414					
EXAMINER <i>Douglas Wells</i>					DATE CONSIDERED <i>3 Mar 05</i>		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant							